



ELECTRONIC COPY

LG784657679
Report verification at igi.org



March 27, 2026
IGI Report Number **LG784657679**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **OVAL BRILLIANT**
Measurements **10.90 X 6.90 X 4.26 MM**
GRADING RESULTS
Carat Weight **2.02 CARATS**
Color Grade **D**
Clarity Grade **VVS 2**

March 27, 2026
IGI Report Number **LG784657679**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **OVAL BRILLIANT**
Measurements **10.90 X 6.90 X 4.26 MM**

GRADING RESULTS

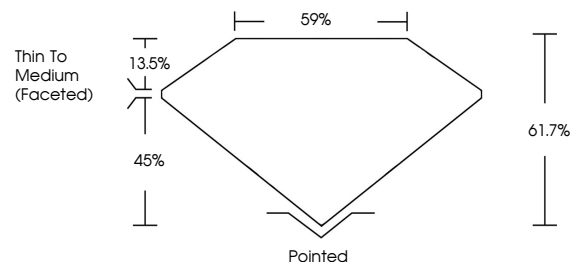
Carat Weight **2.02 CARATS**
Color Grade **D**
Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG784657679**

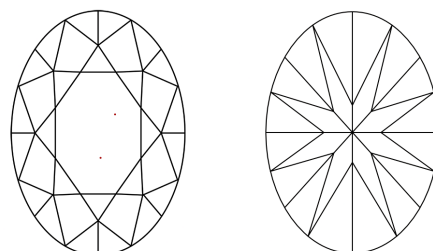
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

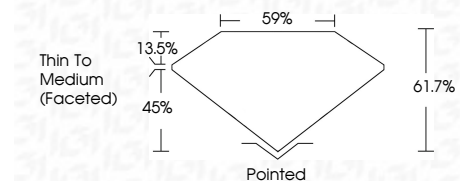
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VVS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG784657679**
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa



IGI



March 27, 2026
IGI Report No **LG784657679**
OVAL BRILLIANT
10.90 X 6.90 X 4.26 MM
Carat Weight **2.02 CARATS**
Color Grade **D**
Clarity Grade **VVS 2**
Depth **61.7%**
Table **59%**
Girdle **Thin To Medium (Faceted)**
Culet **Pointed**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG784657679**
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa